

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Suh, et al.

Serial No. 10/029,158

Filed: December 21, 2001

Title: APPARATUS AND METHOD FOR  
CHEMICAL MECHANICAL POLISHING  
OF SUBSTRATES



Examiner: Unassigned

Group Art Unit: 3723

San Francisco, CA 94111

Date: April 2, 2002

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being sent via U.S. Mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on April 2, 2002.

Signed:

*Kurt Bateman*  
Kurt Bateman

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

Pursuant to 37 C.F.R. 1.136(a), an extension of time of:

	<u>Large Entity</u>	<u>Small Entity</u>
One Month	/X/ \$ 110.00	// \$ 55.00
Two Months	// \$ 400.00	// \$ 200.00
Three Months	// \$ 920.00	// \$ 460.00
Four Months	// \$1,440.00	// \$ 720.00

is hereby requested to:

/X/ response to the Office Action mailed December 21, 2001; the requisite fee pursuant to 37 C.F.R. 1.17 is: /X/ enclosed by Check // to be charged to Deposit Account No. (Order No. \_\_\_\_\_).

/X/ Please charge any additional fees or credit any overpayment to Deposit Account No. 06-1300) (Order No. A-69175-1/AJT/MSS).

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Respectfully submitted,

By:

*Maria S. Swiatek*

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(A-69175-1/AJT/MSS)

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